

PATENT ASSIGNMENT COVER SHEET

Electronic Version v1.1
 Stylesheet Version v1.2

EPAS ID: PAT3752022

SUBMISSION TYPE:	CORRECTIVE ASSIGNMENT
NATURE OF CONVEYANCE:	Corrective Assignment to correct the ASSIGNOR/INVENTOR NAME previously recorded on Reel 037658 Frame 0933. Assignor(s) hereby confirms the CORRECT ASSIGNOR/INVENTOR NAME IS QIANG FAN.
CONVEYING PARTY DATA	
Name	Execution Date
QIANG FAN	01/28/2016
RECEIVING PARTY DATA	
Name:	SEMICONDUCTOR MANUFACTURING INTERNATIONAL (SHANGHAI) CORPORATION
Street Address:	18 ZHANGJIANG ROAD
Internal Address:	PUDONG NEW AREA
City:	SHANGHAI
State/Country:	CHINA
Postal Code:	201203
PROPERTY NUMBERS Total: 1	
Property Type	Number
Application Number:	15014853
CORRESPONDENCE DATA	
Fax Number:	(408)638-0326
<i>Correspondence will be sent to the e-mail address first; if that is unsuccessful, it will be sent using a fax number, if provided; if that is unsuccessful, it will be sent via US Mail.</i>	
Phone:	408-331-1670
Email:	jfosnaugh@innovationcounsel.com
Correspondent Name:	INNOVATION COUNSEL LLP
Address Line 1:	2880 LAKESIDE DRIVE
Address Line 2:	SUITE 200
Address Line 4:	SANTA CLARA, CALIFORNIA 95054
ATTORNEY DOCKET NUMBER:	PCAS00057 US
NAME OF SUBMITTER:	YI-MING TSENG, REG. NO. 56,454
SIGNATURE:	/Yi-Ming Tseng/
DATE SIGNED:	02/23/2016
Total Attachments: 7	
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PATENT ASSIGNMENT COVER SHEET

Electronic Version v1.1
Stylesheet Version v1.2

EPAS ID: PAT3725445

SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT
CONVEYING PARTY DATA	
Name	Execution Date
QI FAN	01/28/2016
RECEIVING PARTY DATA	
Name:	SEMICONDUCTOR MANUFACTURING INTERNATIONAL (SHANGHAI) CORPORATION
Street Address:	18 ZHANGJIANG ROAD
Internal Address:	PUDONG NEW AREA
City:	SHANGHAI
State/Country:	CHINA
Postal Code:	201203
PROPERTY NUMBERS Total: 1	
Property Type	Number
Application Number:	15014853
CORRESPONDENCE DATA	
Fax Number:	(408)638-0326
<i>Correspondence will be sent to the e-mail address first; if that is unsuccessful, it will be sent using a fax number, if provided; if that is unsuccessful, it will be sent via US Mail.</i>	
Phone:	408 331 1670
Email:	jfosnaugh@innovationcounsel.com
Correspondent Name:	INNOVATION COUNSEL LLP
Address Line 1:	2880 LAKESIDE DRIVE
Address Line 2:	SUITE 200
Address Line 4:	SANTA CLARA, CALIFORNIA 95054-2818
ATTORNEY DOCKET NUMBER:	PCAS00057 US
NAME OF SUBMITTER:	YI-MING TSENG, REG. NO. 56,454
SIGNATURE:	/Yi-Ming Tseng/
DATE SIGNED:	02/03/2016
Total Attachments: 1	
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ASSIGNMENT

For good and valuable consideration, receipt of which is hereby acknowledged, we

Qiang FAN of 18 Zhangjiang Road
Pudong New Area
Shanghai, P.R.C. 201203

hereby sell, assign and transfer to **Semiconductor Manufacturing International (Shanghai) Corporation**, having a place of business at 18 Zhangjiang Road, Pudong New Area, Shanghai, P.R.C. 201203, its successors and assigns, the entire right, title and interest throughout the world in my invention in

**METHOD AND APPARATUS FOR FACILITATING MANUFACTURING OF
SEMICONDUCTOR DEVICE**

for which I have executed a United States patent application on or about the date of this assignment, and all patent applications and patents of every country for said invention, including divisionals, reissues, continuations and extensions thereof, and all rights of priority resulting from the filing of said applications; I authorize the above-named assignee to apply for patents of foreign countries for said invention, and to claim all rights of priority without further authorization from me; I agree to execute all papers useful in connection with said United States and foreign applications, and generally to do everything possible to aid said assignee, its successors, assigns and nominees, at their request and expense, in obtaining and enforcing patents for said invention in all countries; and I request that the United States Patent and Trademark Office issue all patents granted for said invention to the above-named assignee, its successors and assigns.

Executed this 20th day of Jan., 2016.

Qiang Fan

Qiang FAN

WITNESSED: Li jin xia

Signature Li jin xia

Date 2016. 01. 28

Type or print name of witness